



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 3652
Examiner: James J. Keenan

In Re PATENT APPLICATION Of:

Applicants :	Muh-Wang LIANG et al.)
Serial No. :	09/619,388)
Filed :	July 19, 2000)
For :	APPARATUS FOR LOADING/UNLOADING WAFERS TO AND FROM SEMICONDUCTOR FABRICATION EQUIPMENT)
Attorney Ref. :	LIE 105)

AMENDMENT

August 23, 2004

Mail Stop Non-Fee Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

Dear Sir:

This is in response to the Office Action dated June 23, 2004 in connection with the above-identified patent application. Please amend the subject patent application as follows: